

In re the Application of: Tomoharu NAKANO et al.

Group Art Unit: 1755

Application Number: 10/552,606

Examiner: Not yet assigned

Filed: **April 6, 2007**

Confirmation Number: 6380

For:

POLISHING LIQUID FOR CMP PROCESS AND POLISHING

METHOD

Attorney Docket Number:

052463

Customer Number:

38834

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97(b)

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450 June 13, 2007

Sir:

In compliance with 37 C.F.R. §1.56, Applicants direct the attention of the Patent and Trademark Office to the documents listed on the attached PTO/SB/08. This paper is being filed within the time periods set forth in 37 C.F.R. §1.97(b). A copy of each non-U.S. document is enclosed herewith.

Documents 1-4 were cited in an Office Action for a corresponding Chinese application. A copy of the Office Action with an English translation is also enclosed.

If there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

Limited Recognition

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SY/mt

Enclosures:

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PTO/SB/08

Foreign Communication

4 Documents



Combined Form PTO/SB/08A&B

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet 1 of 1

Complete if Known				
Application Number	10/552,606			
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Filing Date	April 6, 2007			
First Named Inventor	Tomoharu NAKANO et al.			
Art Unit	1755			
Examiner Name	Not yet assigned			
Attorney Docket Number	052463			

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Document	Number	Publication Date MM-DD-YYYY		
		Number	Kind Code ² (if known)		Name of Patentee or Applicant of Cited Documen	
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FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No. ¹	Foreign Patent Document			Publication Date	Name of Patentee or	
		Country Code ³	Number ⁴	Kind Code ⁵ (if known)	MM-DD-YYYY	Applicant of Cited Document	Translation ⁶
	1	CN	1395295	Α	02-05-2003	Hitachi Ltd.	No
	2	CN	1185471	Α	06-24-1998	Fujimi Incorporated	No
	3	WO	03/032379	A1	04-17-2003	Hitachi Chemical Co., Ltd.	Abstract
	4	CN	1304968	A	07-25-2001	Tsinghua University	No
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		NON PATENT LITERATURE DOCUMENTS			
Examiner Cite Initials* No.1		Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.			
	5	Chinese Office Action dated April 27, 2007 of CN 200480012569.4	Yes		
					
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English and Class advisor	D-4. C 1 1	
Examiner Signature	Date Considered	
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^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Applicant's unique citation designation number (optional). ²See Kind Codes of USPTO Patent Documents at www.uspto.gov, MPEP 901.04 or in the comment box of this document. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to indicate here if English language Translation is attached.